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Rib Data Sheet

CONFIRMATION NO. 3893

| BID Data Sheet | | | | | | | | | |
|--|---|-------------------------------------|---|--------------|------------------------|---|-------------|---|-------------|
| SERIAL NUMB 10/019,407 | ER _. | FILING DATE 03/25/2002 RULE | C | CLASS 438 | GROUP ART UNIT 2813 | | UNIT | ATTORNEY DOCKET NO. 520.41003 X00 | |
| APPLICANTS | | | | , | | | | | |
| Yoshinobu | Kimı | ıra, Tokyo, JAPAN; | | | | | | | |
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| ** CONTINUING DATA ********************************** | | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | |
| Foreign Priority claimed | | | | STATE OR | SHE | ETS | тот | AL | INDEPENDENT |
| 35 USC 119 (a-d) conditions yes no Met after met Allowance Verified and Acknowledged Examiner's Signature Intials JAPAN 16 20 | | | | | | | CLAIMS 9 | | |
| | VEN | STOUT & KRAUS, LLI TEENTH STREET | , | | | | | | |
| TITLE Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device | | | | | | | | | |
| | FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: | | | | | All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) | | | |
| RECEIVED | | | | | | | | | |

| 1524 | 1.18 Fees (Issue) |
|------|-------------------|
| | □ Other |
| | ☐ Credit |